

<b>Notice of References Cited</b>	Application/Control No. 10/659,475	Applicant(s)/Patent Under Reexamination SCHLIPALIUS ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,780,056	07-1998	Akamatsu et al.	424/464
	B	US-5,004,756	04-1991	Ogawa et al.	514/655
	C	US-			
	D	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

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